


CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)			Docket No. FIS920030051US1
Applicant(s): Steegan et al.			
Application No. 10/604,102	Filing Date 6/26/2003	Examiner Eckert II, George C.	Group Art Unit 2815
Invention: SELECTIVE SILICON-ON-INSULATOR ISOLATION STRUCTURES AND METHOD			
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.: 10/604,102

Applicant(s): Stecgan et al.

Filed.: June 26, 2003

Art Unit: 2815

Dkt. No.: FIS920030051

Examiner: Eckert II, George C.

Title: **SELECTIVE SILICON-ON-INSULATOR ISOLATION STRUCTURES AND METHOD**

Honorable Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

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REQUEST FOR RECONSIDERATION

This Request for Reconsideration is being filed in response to the Office Action mailed on October 5, 2004.

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1